

Docket No. BUR9-2001-0105-US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Radens *et al.*

Group Art Unit: 2811

Filed: 04/17/2002

Examiner: Loke, Steven Ho Yin

Serial No.: 10/063,376

Title: MOS ANTIFUSE WITH LOW POST-PROGRAM RESISTANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed April 22, 2003, please amend the above-identified application as follows:

10/063,376

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#6/B
Amend B
Y Robinson
9/10/03